

Electronic Patent Application Fee Transmittal

Application Number:	10768611								
Filing Date:	29-Jan-2004								
Title of Invention:	SEMICONDUCTOR DEVICE WITH NITROGEN IN OXIDE FILM ON SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURING THE SAME								
First Named Inventor/Applicant Name:	Eiji Hasegawa								
Filer:	Max Moskowitz/Cheryl Godfrey								
Attorney Docket Number:	P/29-1647								
Filed as Large Entity									
Utility Filing Fees <table border="1" style="width: 100%; border-collapse: collapse;"> <thead> <tr> <th style="width: 30%;">Description</th> <th style="width: 15%;">Fee Code</th> <th style="width: 15%;">Quantity</th> <th style="width: 15%;">Amount</th> <th style="width: 15%;">Sub-Total in USD(\$)</th> </tr> </thead> </table>					Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)					
Basic Filing:									
Pages:									
Claims:									
Miscellaneous-Filing:									
Petition:									
Patent-Appeals-and-Interference:									
Post-Allowance-and-Post-Issuance:									
Utility Appl Issue fee	1501	1	1400	1400					
Publ. Fee- early, voluntary, or normal	1504	1	300	300					

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1700